

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10581633	
	Filing Date		2006-06-02	
	First Named Inventor	Takayuki Shima		
	Art Unit	2627		
	Examiner Name			
	Attorney Docket Number	690121.407USPC		

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1	Neff, H. et al., "Structural, optical, and electronic properties of magnetron-sputtered platinum oxide films", Journal of Applied Physics, American Institute of Physics. New York, US, vol. 79, no. 10, 15 May 1996, pages 7672-7675, XP002463986.	<input type="checkbox"/>
2	Yi Chiu et al., "Fabrication and nonlinear optical properties of nanoparticle silver oxide films", Journal of Applied Physics, vol. 94, no. 3, 1 August 2003, pages 1996-2001, XP002479469.	<input type="checkbox"/>

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¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.

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☐ That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(1).

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☐ See attached certification statement.

☐ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.

☒ None

SIGNATURE

A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

Signature	/Dennis M. de Guzman/	Date (YYYY-MM-DD)	2008-07-09
Name/Print	Dennis M. de Guzman	Registration Number	41,702

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